

JUL 11 2006

Docket No. 212/543

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re Application of:

Dalrymple et al.

Serial No.: 10/754,360

Art Unit: 1763

Filed: January 8, 2004

For: Devices and Methods for
Optical Endpoint Detection
During Semiconductor Wafer
Polishing

Examiner: MacArthur, Sylvia

RESPONSE TO OFFICE ACTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is responsive to the Office Action dated April
11, 2006.

Certificate of facsimile transmission

I hereby certify that this response (along with any paper referred to as being
attached or enclosed) is being facsimile transmitted to the Commissioner for Patents,
P.O. Box 1450, Alexandria, VA 22313-1450 at the facsimile telephone number indicated
below.

Fax No. 5712738300
Date: July 11, 2006

Marc J. Frechette, Esq.